



Attorney Docket No. 09792909-5337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Hideo Yamanaka et al.

Application No. 10/075,774

Filed: February 14, 2002

For: METHOD AND APPARATUS FOR
FORMING A THIN SEMICONDUCTOR
FILM, METHOD AND APPARATUS FOR
PRODUCING A SEMICONDUCTOR
DEVICE, AND ELECTRO-OPTICAL
APPARATUS

) Group Art Unit 2814

) Examiner: Hoa B. Trinh

I hereby certify that this document is being deposited with
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1450, Alexandria, VA 22313-1450 on November 6, 2004.

Enrique Perez

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

This Amendment is filed in response to the Office Action of May 7, 2004. Please
reconsider the application in view of the amendment and remarks presented below.